

INFORMATION DISCLOSURE CITATION

PTO-1449

 ATTY. DOCKET NO.
9840-055-999

 SERIAL NO.
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 APPLICANT
Conant et al.

 FILING DATE
May 31, 2000

 GROUP
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 50511 U.S. PTO
09/564835
05/31/00

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

ML	Yao and MacDonald, "Single Crystal Silicon Supported Thin Film Micromirrors for Optical Applications", <i>Opt. Eng.</i> , 36 (5):1408-1413 (May 1997)
ML	Yeh et al., "Integrated Polysilicon and DRIE Bulk Silicon Micromachining for an Electrostatic Torsional Actuator", <i>J. Microelectromechanical Systems</i> , 8 (4):456-465 (Dec. 1999)

EXAMINER

Robin

DATE CONSIDERED

1/30/02

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9840-055-999

09/584,835

Conant et al.

May 31, 2001

2872

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LIST OF REFERENCES CITED BY APPLICANT

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APPLICATION NO.

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U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
MR	6,201,629	3/13/01	McClelland et al.	359	223	

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
					YES	NO

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

Robinson

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